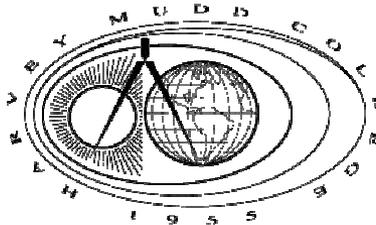


# **Introduction to CMOS VLSI Design**

## **Lecture 15: Nonideal Transistors**

David Harris



Harvey Mudd College

Spring 2004

# Outline

---

- ❑ Transistor I-V Review
- ❑ Nonideal Transistor Behavior
  - Velocity Saturation
  - Channel Length Modulation
  - Body Effect
  - Leakage
  - Temperature Sensitivity
- ❑ Process and Environmental Variations
  - Process Corners

# Ideal Transistor I-V

- Shockley 1<sup>st</sup> order transistor models

$$I_{ds} = \begin{cases} 0 & V_{gs} < V_t & \text{cutoff} \\ \mathbf{b} \left( V_{gs} - V_t - \frac{V_{ds}}{2} \right) V_{ds} & V_{ds} < V_{dsat} & \text{linear} \\ \frac{\mathbf{b}}{2} (V_{gs} - V_t)^2 & V_{ds} > V_{dsat} & \text{saturation} \end{cases}$$

# Ideal nMOS I-V Plot

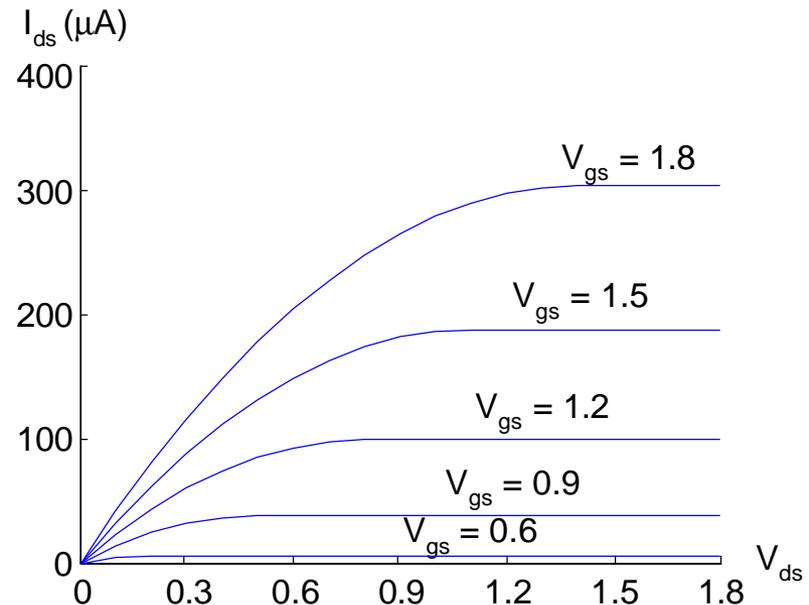
❑ 180 nm TSMC process

❑ Ideal Models

–  $\beta = 155(W/L) \mu\text{A}/\text{V}^2$

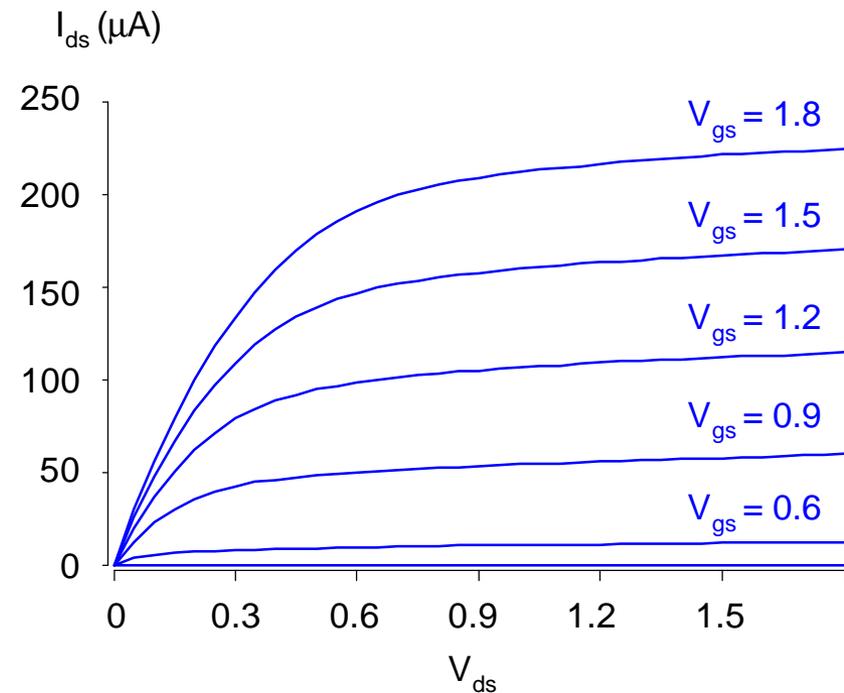
–  $V_t = 0.4 \text{ V}$

–  $V_{DD} = 1.8 \text{ V}$



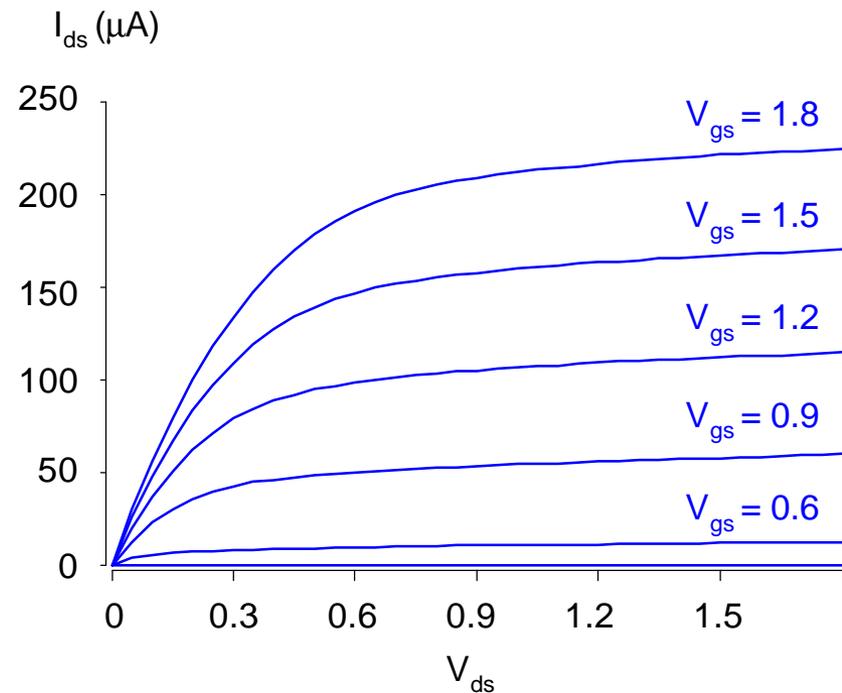
# Simulated nMOS I-V Plot

- ❑ 180 nm TSMC process
- ❑ BSIM 3v3 SPICE models
- ❑ What differs?



# Simulated nMOS I-V Plot

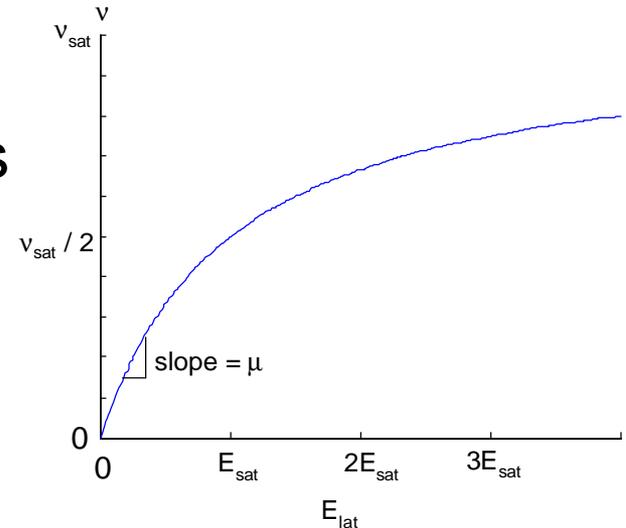
- ❑ 180 nm TSMC process
- ❑ BSIM 3v3 SPICE models
- ❑ What differs?
  - Less ON current
  - No square law
  - Current increases in saturation



# Velocity Saturation

- ❑ We assumed carrier velocity is proportional to E-field
  - $v = \mu E_{\text{lat}} = \mu V_{\text{ds}}/L$
- ❑ At high fields, this ceases to be true
  - Carriers scatter off atoms
  - Velocity reaches  $v_{\text{sat}}$ 
    - Electrons:  $6-10 \times 10^6$  cm/s
    - Holes:  $4-8 \times 10^6$  cm/s
  - Better model

$$v = \frac{\mu E_{\text{lat}}}{1 + \frac{E_{\text{lat}}}{E_{\text{sat}}}} \Rightarrow v_{\text{sat}} = \mu E_{\text{sat}}$$



# Vel Sat I-V Effects

- ❑ Ideal transistor ON current increases with  $V_{DD}^2$

$$I_{ds} = \mu C_{ox} \frac{W}{L} \frac{(V_{gs} - V_t)^2}{2} = \frac{\mathbf{b}}{2} (V_{gs} - V_t)^2$$

- ❑ Velocity-saturated ON current increases with  $V_{DD}$

$$I_{ds} = C_{ox} W (V_{gs} - V_t) v_{max}$$

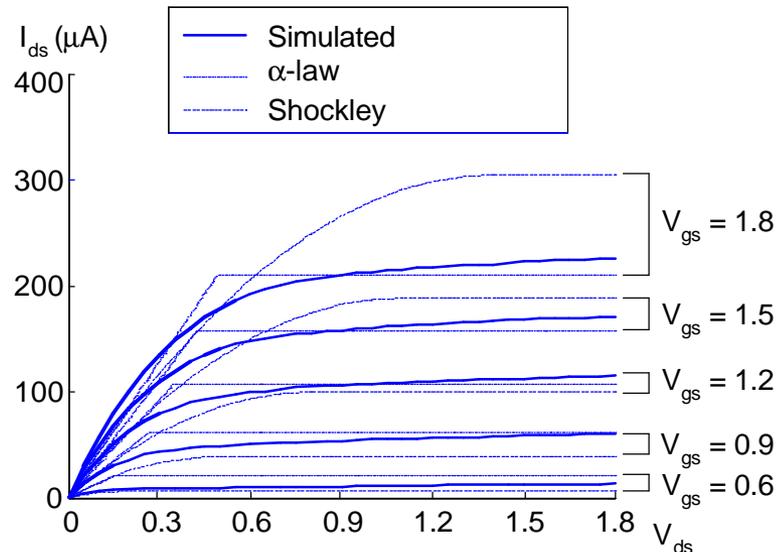
- ❑ Real transistors are partially velocity saturated
  - Approximate with  $\alpha$ -power law model
  - $I_{ds} \propto V_{DD}^\alpha$
  - $1 < \alpha < 2$  determined empirically

# $\alpha$ -Power Model

$$I_{ds} = \begin{cases} 0 & V_{gs} < V_t & \text{cutoff} \\ I_{dsat} \frac{V_{ds}}{V_{dsat}} & V_{ds} < V_{dsat} & \text{linear} \\ I_{dsat} & V_{ds} > V_{dsat} & \text{saturation} \end{cases}$$

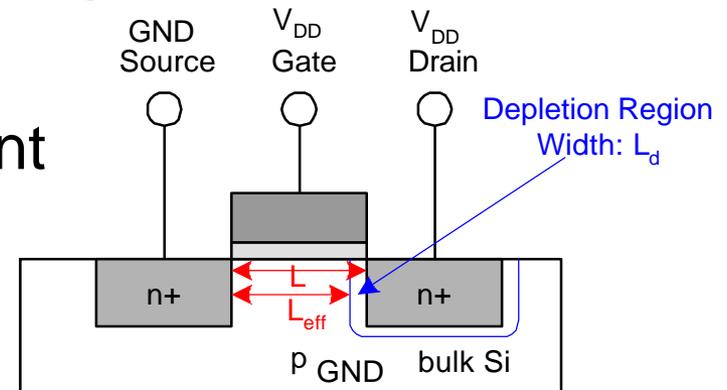
$$I_{dsat} = P_c \frac{b}{2} (V_{gs} - V_t)^a$$

$$V_{dsat} = P_v (V_{gs} - V_t)^{a/2}$$



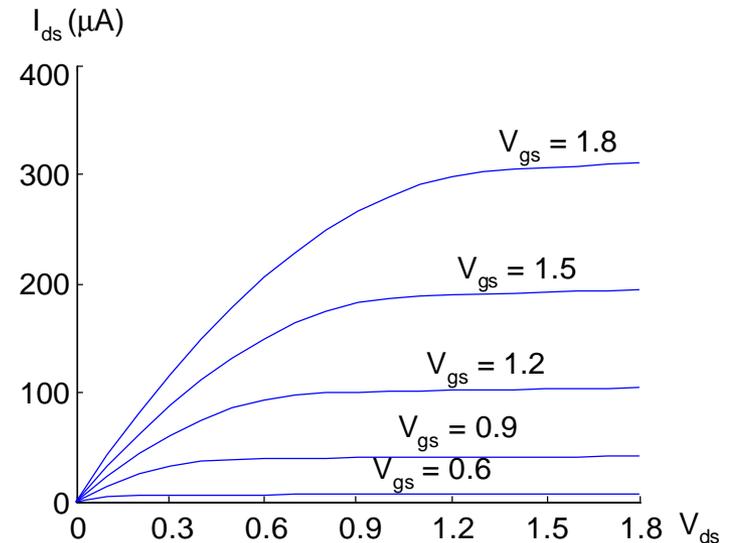
# Channel Length Modulation

- ❑ Reverse-biased p-n junctions form a *depletion region*
  - Region between n and p with no carriers
  - Width of depletion  $L_d$  region grows with reverse bias
  - $L_{\text{eff}} = L - L_d$
- ❑ Shorter  $L_{\text{eff}}$  gives more current
  - $I_{\text{ds}}$  increases with  $V_{\text{ds}}$
  - Even in saturation



# Chan Length Mod I-V

$$I_{ds} = \frac{b}{2} (V_{gs} - V_t)^2 (1 + \lambda V_{ds})$$



- $\lambda =$  channel length modulation coefficient
  - not feature size
  - Empirically fit to I-V characteristics

# Body Effect

- ❑  $V_t$ : gate voltage necessary to invert channel
- ❑ Increases if source voltage increases because source is connected to the channel
- ❑ Increase in  $V_t$  with  $V_s$  is called the *body effect*

# Body Effect Model

$$V_t = V_{t0} + g \left( \sqrt{f_s + V_{sb}} - \sqrt{f_s} \right)$$

□  $\phi_s =$  *surface potential at threshold*

$$f_s = 2v_T \ln \frac{N_A}{n_i}$$

– Depends on doping level  $N_A$

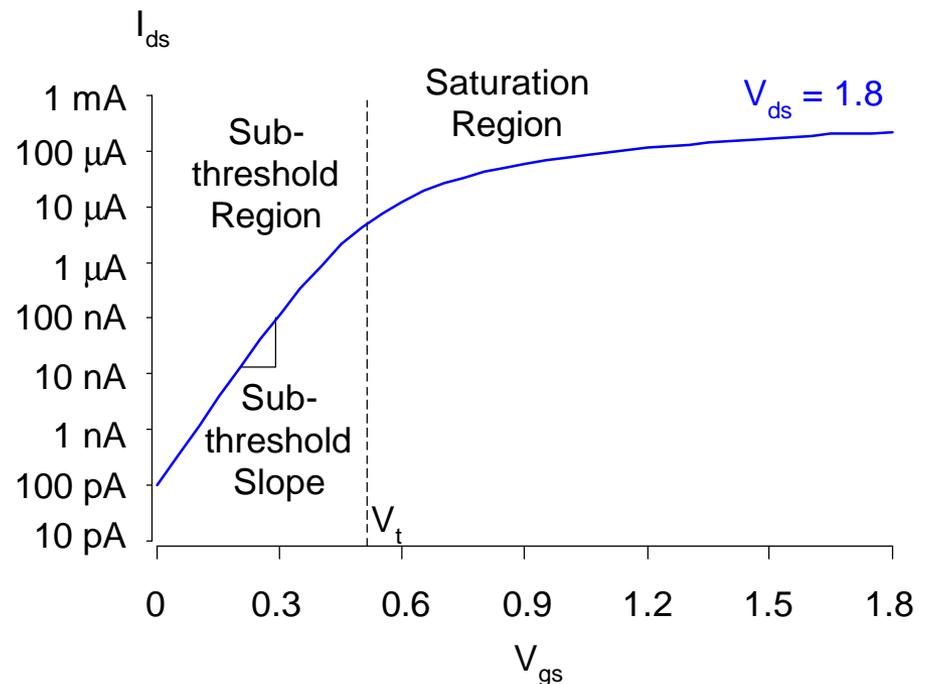
– And intrinsic carrier concentration  $n_i$

□  $\gamma =$  *body effect coefficient*

$$g = \frac{t_{\text{ox}}}{e_{\text{ox}}} \sqrt{2q e_{\text{si}} N_A} = \frac{\sqrt{2q e_{\text{si}} N_A}}{C_{\text{ox}}}$$

# OFF Transistor Behavior

- ❑ What about current in cutoff?
- ❑ Simulated results
- ❑ What differs?
  - Current doesn't go to 0 in cutoff



# Leakage Sources

---

- ❑ Subthreshold conduction
  - Transistors can't abruptly turn ON or OFF
- ❑ Junction leakage
  - Reverse-biased PN junction diode current
- ❑ Gate leakage
  - Tunneling through ultrathin gate dielectric
  
- ❑ Subthreshold leakage is the biggest source in modern transistors

# Subthreshold Leakage

- Subthreshold leakage exponential with  $V_{gs}$

$$I_{ds} = I_{ds0} e^{\frac{V_{gs}-V_t}{nv_T}} \left( 1 - e^{\frac{-V_{ds}}{v_T}} \right) \quad I_{ds0} = \mathbf{b}v_T^2 e^{1.8}$$

- $n$  is process dependent, typically 1.4-1.5

# DIBL

## □ Drain-Induced Barrier Lowering

- Drain voltage also affect  $V_t$

$$V'_t = V_t - \mathbf{h}V_{ds}$$

- High drain voltage causes subthreshold leakage to \_\_\_\_\_.

# DIBL

## □ Drain-Induced Barrier Lowering

- Drain voltage also affect  $V_t$

$$V'_t = V_t - \mathbf{h}V_{ds}$$

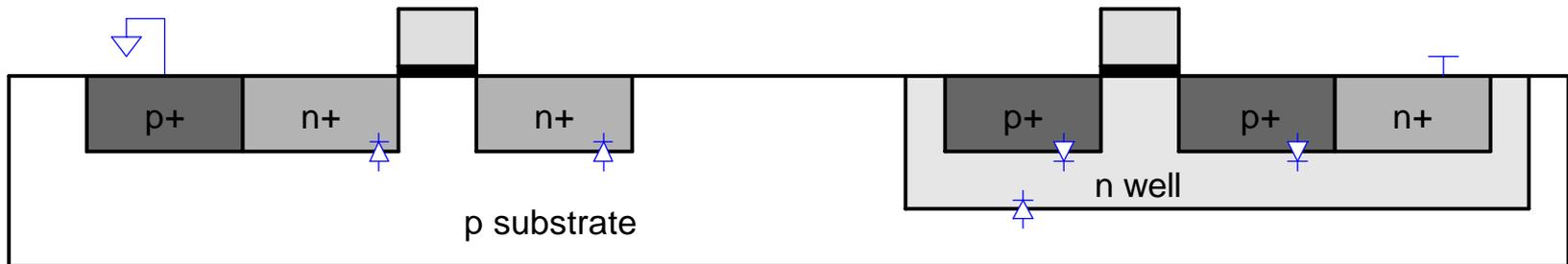
- High drain voltage causes subthreshold leakage to **increase**.

# Junction Leakage

- ❑ Reverse-biased p-n junctions have some leakage

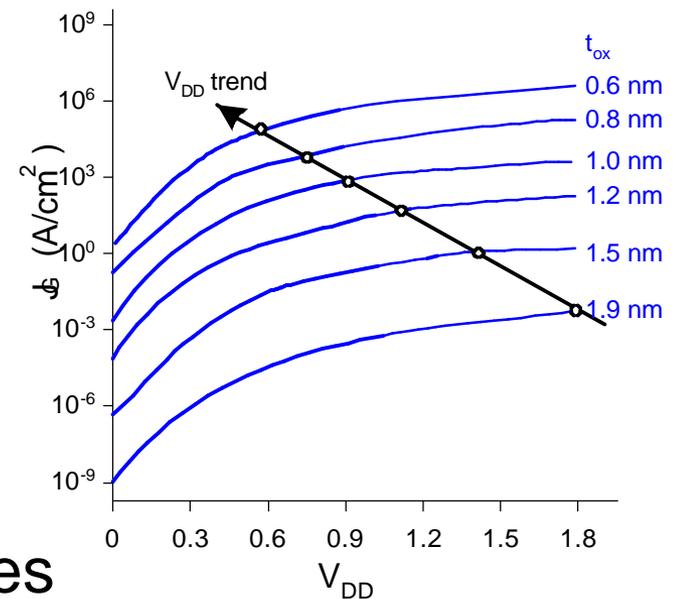
$$I_D = I_S \left( e^{\frac{V_D}{V_T}} - 1 \right)$$

- ❑  $I_S$  depends on doping levels
  - And area and perimeter of diffusion regions
  - Typically  $< 1 \text{ fA}/\mu\text{m}^2$



# Gate Leakage

- ❑ Carriers may tunnel through very thin gate oxides
- ❑ Predicted tunneling current (from [Song01])



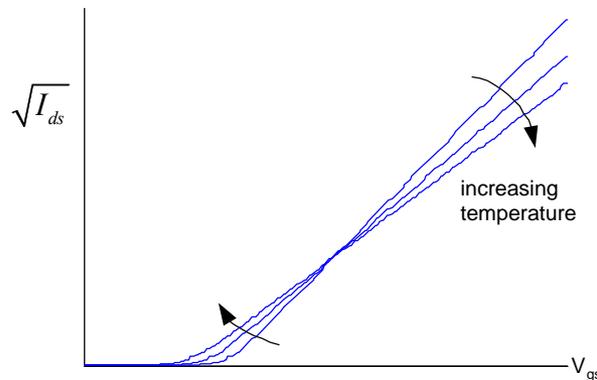
- ❑ Negligible for older processes
- ❑ May soon be critically important

# Temperature Sensitivity

- ❑ Increasing temperature
  - Reduces mobility
  - Reduces  $V_t$
- ❑  $I_{ON}$  \_\_\_\_\_ with temperature
- ❑  $I_{OFF}$  \_\_\_\_\_ with temperature

# Temperature Sensitivity

- ❑ Increasing temperature
  - Reduces mobility
  - Reduces  $V_t$
- ❑  $I_{ON}$  **decreases** with temperature
- ❑  $I_{OFF}$  **increases** with temperature

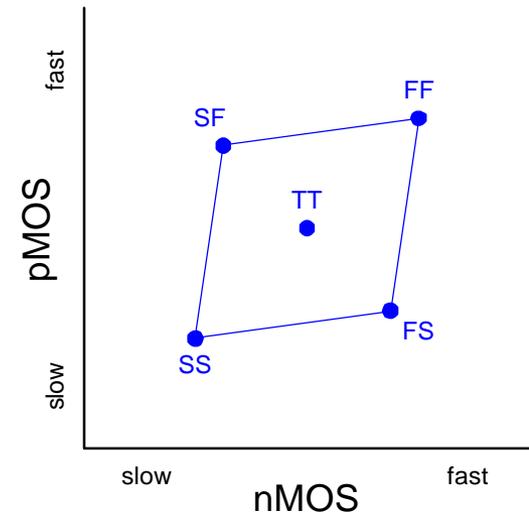


# So What?

- ❑ So what if transistors are not ideal?
  - They still behave like switches.
- ❑ But these effects matter for...
  - Supply voltage choice
  - Logical effort
  - Quiescent power consumption
  - Pass transistors
  - Temperature of operation

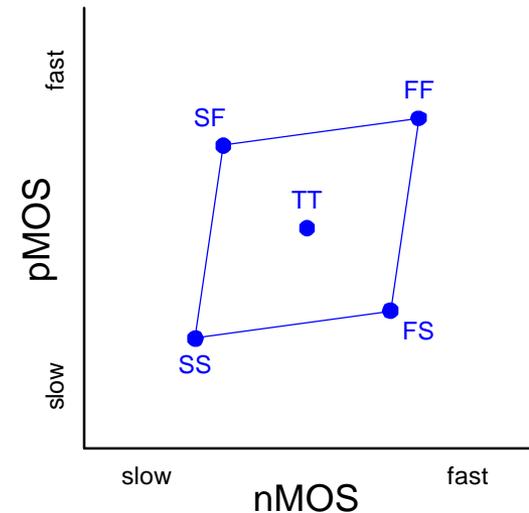
# Parameter Variation

- ❑ Transistors have uncertainty in parameters
  - Process:  $L_{\text{eff}}$ ,  $V_t$ ,  $t_{\text{ox}}$  of nMOS and pMOS
  - Vary around typical (T) values
- ❑ Fast (F)
  - $L_{\text{eff}}$ : \_\_\_\_\_
  - $V_t$ : \_\_\_\_\_
  - $t_{\text{ox}}$ : \_\_\_\_\_
- ❑ Slow (S): opposite
- ❑ Not all parameters are independent for nMOS and pMOS



# Parameter Variation

- ❑ Transistors have uncertainty in parameters
  - Process:  $L_{\text{eff}}$ ,  $V_t$ ,  $t_{\text{ox}}$  of nMOS and pMOS
  - Vary around typical (T) values
- ❑ Fast (F)
  - $L_{\text{eff}}$ : short
  - $V_t$ : low
  - $t_{\text{ox}}$ : thin
- ❑ Slow (S): opposite
- ❑ Not all parameters are independent for nMOS and pMOS



# Environmental Variation

- ❑  $V_{DD}$  and  $T$  also vary in time and space
- ❑ Fast:
  - $V_{DD}$ : \_\_\_\_\_
  - $T$ : \_\_\_\_\_

Corner	Voltage	Temperature
F		
T	1.8	70 C
S		

# Environmental Variation

- ❑  $V_{DD}$  and  $T$  also vary in time and space
- ❑ Fast:
  - $V_{DD}$ : high
  - $T$ : low

Corner	Voltage	Temperature
F	1.98	0 C
T	1.8	70 C
S	1.62	125 C

# Process Corners

- ❑ Process corners describe worst case variations
  - If a design works in all corners, it will probably work for any variation.
- ❑ Describe corner with four letters (T, F, S)
  - nMOS speed
  - pMOS speed
  - Voltage
  - Temperature

# Important Corners

- ❑ Some critical simulation corners include

Purpose	nMOS	pMOS	$V_{DD}$	Temp
Cycle time				
Power				
Subthreshold leakage				
Pseudo-nMOS				

# Important Corners

- ❑ Some critical simulation corners include

Purpose	nMOS	pMOS	$V_{DD}$	Temp
Cycle time	S	S	S	S
Power	F	F	F	F
Subthreshold leakage	F	F	F	S
Pseudo-nMOS	S	F	?	?